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AF/2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Youngmin Kim, et al. Docket No: TI-29012
Serial No: 09/574,653 Conf. No: 8503
Examiner: Hsien Ming Lee Art Unit: 2823
Filed: 05/18/2000
For: A TUNABLE SIDEWALL SPACER PROCESS FOR CMOS INTEGRATED CIRCUITS

AMENDMENT PURSUANT TO 37 CFR 1.116

Mail Stop AF
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8(a)
I hereby certify that the above correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 10-6-03.


Ann Trent

Dear Sir:

Responsive to the Office Action mailed August 4, 2003, in connection with the above identified application, Applicants respectfully submit the following amendments and remarks.

RECEIVED
OCT 10 2003
TECHNOLOGY CENTER 2800

Amendments to the Specification:

None